



Docket No.: 50212-535

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Yoshiki NISHIBAYASHI, et al.	:	Confirmation Number: 8079
Serial No.: 10/661,591	:	Group Art Unit: 1765
Filed: September 15, 2003	:	Examiner: Unknown
For: MICROFABRICATED DIAMOND ELEMENT AND METHOD OF FABRICATING MICROFABRICATED DIAMOND ELEMENT	:	

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.


The relevance of the references listed on attached Form 1449 is discussed in the present specification.

10/661,591

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Arthur J. Steiner
Registration No. 26,106

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 AJS:tlb
Facsimile: (202) 756-8087
Date: January 15, 2004

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.